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Our Case No. 7103/261 (P0704)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Radman

Serial No.: 09/843,323

Filing Date: April 25, 2001

For: SPHERICAL CAP-SHAPED
POLISHING HEAD IN A
CHEMICAL MECHANICAL
POLISHING APPARTUS FOR
SEMICONDUCTOR WAFERS

DEXaminer: M. Rachuba
Group Art Unit No. 3723

## AMENDMENT AFTER FINAL REJECTION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In reply to the Office Action dated September 17, 2003, Applicant has filed this Amendment by Certificate of Mailing. Applicant respectfully requests the Examiner to withdraw the objections and rejections to this application and to grant allowance of this Application in view of the following remarks and amended claims.

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